DuPont[™] Kalrez[®] 8900

For Semiconductor Thermal Processes

Technical Information— January 2012

Product Description

DuPont™ Kalrez® 8900 perfluoroelastomer parts are a black product for all thermal processes, e.g., oxidation, diffusion furnace, metal CVD, ALD and LPCVD. It offers outstanding thermal stability, very low outgassing and excellent (low) compression set properties. Kalrez® 8900 parts exhibit excellent retention of physical properties at elevated temperatures, have excellent mechanical strength and are well-suited for both static and dynamic sealing applications. A maximum continuous service temperature of 325 °C is suggested. Short excursions to higher temperatures may also be possible. Ultrapure post-cleaning and packaging is standard for all Kalrez® 8900 parts.



Features/Benefits

- · Outstanding thermal stability
- · Excellent (low) compression set properties
- Very low outgassing properties
- · Very low moisture content
- Excellent retention of physical properties at elevated temperatures
- · Excellent resistance to fluorine gas

Suggested Applications

- Quartz Tube Seals
- Plenum Seals
- · Chamber Seals
- Fittings
- · Center Ring Seals

Typical Physical Properties ¹	
Color	Black
Hardness ² , Shore A (pellet)	73
Hardness ³ , Shore M (O-ring)	82
100% Modulus ⁴ , MPa	12.21
Tensile Strength at Break ⁴ , MPa	20.75
Elongation at Break ⁴ , %	137
Compression Set ⁵ , %	
70 hr at 204 °C	9
70 hr at 300 °C	32
70 hr at 325 °C	59
Maximum Continuous Service,	
Temperature ⁶ , °C	325

Not to be used for specification purposes

Fabs Choose Kalrez® 8900 for Improved Performance

Kalrez[®] 8900 has been reported to significantly improve wafer production in semiconductor thermal process applications where aggressive gases are used during the cleaning cycle.



² ASTM D2240 (pellet test specimens)

³ ASTM D2240 and D1414 (AS568 K214 O-ring test specimens)

⁴ ASTM D412 (dumbbell test specimens)

⁵ ASTM D395B and D1414 (AS568 K214 O-ring test specimens)

⁶ DuPont proprietary test method

Case Report #11069 — Exceeded 4 Month PM Target at Major AP Fabline

- Exhibited less degradation than incumbent seals after 5 months in service
- Equipment Platform Major Japanese OEM
- Process LPCVD Nitride
- Process Chemistry Si₂Cl₆, NH₃
- Cleaning Chemistry HF + F₂ at 150 °C
- Seal Locations Complete seal kit

Case Report #11932 — Improved Performance vs Incumbent at Major AP Fab Line

- No evidence of degradation in aggressive seal locations after 6 months of service
- Equipment Platform Major Japanese OEM
- Process LPCVD Nitride
- Process Chemistry SiH₂Cl₂, NH₃
- Cleaning Chemistry HF + F₂
- · Seal Location Complete seal kit

Case Report #12007 —3x Improvement in Seal Life @ Major US Fabline

- · Eliminated excessive seal leakage and particle contamination versus incumbent seals
- Equipment Platform -- HKE Quikace Furnace
- Processes -- Diffusion Radical Oxide & Pyro
- Process Chemistry -- H₂, O₂, N₂, N₂O
- · Cleaning Chemistry -- HCI
- · Seal Locations -- G400 O-ring and upper quartz cap seal

Visit us at kalrez.dupont.com or vespel.dupont.com

Contact DuPont at the following regional locations:

 North America
 Latin America
 Europe, Middle East, Africa

 800-222-8377
 +0800 17 17 15
 +41 22 717 51 11

Greater China ASEAN Japan

+86-400-8851-888 +65-6586-3688 +81-3-5521-8484

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